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PATENT APPLICATION**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q78921

Shigeo NOJIMA, et al.

Appln. No.: 10/736,235

Group Art Unit: 2861

Confirmation No.: 7674

Examiner: Hai Chi PHAM

Filed: December 16, 2003

For: ORGANIC EL ARRAY EXPOSURE HEAD, IMAGING SYSTEM INCORPORATING THE SAME, AND ARRAY-FORM EXPOSURE HEAD FABRICATION PROCESS

RESPONSE TO RESTRICTION REQUIREMENT**MAIL STOP AMENDMENT**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

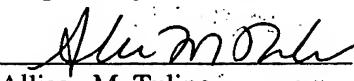
Sir:

In response to the Restriction Requirement dated December 15, 2005, Applicant elects, without traverse, the invention designated by Group I inclusive of claims 1-17. Applicant reserves the right to file a Divisional Application directed to non-elected Group II.

It is respectfully requested that examination of the above application proceed on the basis of the election which has been made.

The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

Respectfully submitted,



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